

08-29-2000

83-00



101445607

PATENT
03141-P0105A WWW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Assignor:	Perkin-Elmer Corporation
Assignee:	Perkin Elmer LLC
Patent No. 4,417,189	Issue Date: November 22, 1983
Title of Application:	Control Circuit For Stepper Motor

Box Assignment
Assistant Commissioner for Patents
Washington, DC 20231

Assignment Recordation Form Cover Sheet

Dear Sir:

Please record the attached original document.

1. Name of conveying party(ies). Perkin-Elmer Corporation
2. Name and Address of Receiving Party. Perkin Elmer LLC, a Delaware Limited Liability Company having offices located at 761 Main Avenue; Norwalk, CT 06859-0119.
3. Nature of Conveyance: Assignment. Execution Date: July 18, 2000
4. Name and Address of Party to Whom Correspondence Concerning Document should be mailed.

Wesley W. Whitmyer, Jr., Registration No. 33,558
Attorney for Assignee
ST.ONGE STEWARD JOHNSTON & REENS LLC
986 Bedford Street
Stamford, CT 06905-5619
203 324-6155

08/29/2000 DNGUYEN 00000326 4417189

01 FC:581

40.00 OP

Mailing Certificate: I hereby certify that this correspondence is today being deposited with the U.S. Postal Service as *First Class Mail* in an envelope addressed to: Box Assignment; Commissioner of Patents and Trademarks; Washington, DC 20231.

July 2, 2000
Aug

Danielle B. Dominici

PATENT
REEL: 011019 FRAME: 0497

5. Patent Number: 4,417,189.
6. Total Number of Patents Involved: 1.
7. Total Fee (37 CFR 3.41). \$40.00 due. A check for this amount is enclosed.
8. Authorization to Charge Deposit Account. The Commissioner is hereby authorized to charge any additional fees due by this paper and during the entire pendency of this Application to Account No. 19-4516.
9. Statement and Signature. Total number of pages including cover sheet, attachments and document are 16. To the best of my knowledge and belief, the foregoing information is true and correct.

Respectfully submitted,



Wesley W. Whitmyer, Jr., Registration No. 33,558
Attorney for Assignee
ST.ONGE STEWARD JOHNSTON & REENS LLC
986 Bedford Street; Stamford, CT 06905-5619
Telephone: 203 324-6155

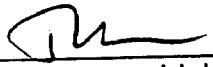
CONFIRMATORY ASSIGNMENT

WHEREAS, Perkin Elmer LLC is desirous of recording its ownership of the patents and patent applications listed on the attached Exhibit A in the various Patent Offices throughout the world;

In consideration of the sum of one dollar (\$1.00) and other good and valuable consideration, the receipt of which is acknowledged, Perkin-Elmer Corporation whose post office address is 761 Main Avenue; Norwalk, CT 06859, hereby conveys, assigns and transfers its entire right, title and interest in and to the patents and patent applications listed on the attached exhibit A, including but limited to the right to sue and collect damages for past infringement of said Patents to Perkin Elmer LLC, a Delaware corporation whose post office address is, 761 Main Avenue; Norwalk, CT 06859.

Executed this 18th day of July, 2000, at Connecticut, [State].

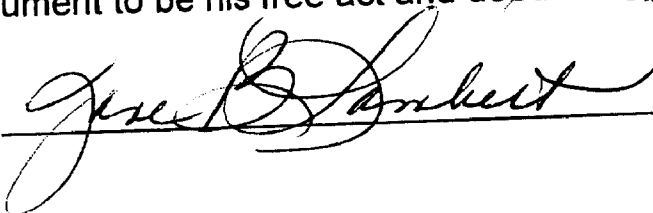
(Assignor)
Perkin-Elmer Corporation (*now named PE Corporation (NY)*)

By 
Name: Thomas Livingston
Title: ~~Assistant~~ Secretary

State of Connecticut
County of Fairfield ss.

Before me personally appeared Thomas Livingston and acknowledged the foregoing instrument to be his free act and deed this 18 day of July, 2000.

Notary Public



4411	P0047AJP	Flow Regulation In Gas Chromatograph	Japan	Pending		4515/106	1986/03/01
4427	P004BAEP	Solid State Inductively Coupled Plasma Generator	Europe	Pending	005/15/2	9712/1904.5	1997/12/12
4430	P004BAJP	Solid State Inductively Coupled Plasma Generator	Japan	Published		10000481	1990/01/05
4430	P004BAEP	Gas Chromatographic System With Controlled Sample Transfer	Europe	Pending	077/0889	9611/7016.4	1986/10/23
4431	P0050AJP	Gas Chromatographic System With Controlled Sample Transfer	Japan	Pending	077/0463	9611/10387.7	1986/10/23
4431	P0050AEP	Calorimeter Having Rapid Cooling Of A Heating Vessel Therein	Europe	Granted	9.178.577	328552/96	1986/12/08
4432	P0051AEP	Calorimeter Having Rapid Cooling Of A Heating Vessel Therein	Japan	Granted		9611/3491.3	1986/08/22
4432	P0051AJP	Thermal Insulating Container For Liquefied Gas	Europe	Published		236394/98	1986/08/06
4433	P0052AEP	Thermal Insulating Container For Liquefied Gas	Japan	Pending	077/0439	9611/3495.1	1986/12/03
4433	P0052AJP	Connecting Apparatus For Conveyance Of Cryogenic Fluid	Europe	Pending		328554/96	1986/12/08
4434	P0053AEP	Fluid Conveying Device With Removable Connection	Japan	Published	0762/033	9611/3490.5	1986/08/06
4435	P0054AEP	Fluid Conveying Device With Removable Connection	Europe	Pending		1986/07/04	1986/10/23
4435	P0054AJP	Dry Gas Curtain For Cryogenic Surfaces	Japan	Pending	0762/034	9611/0836.2	1986/10/23
4440	P0055AEP	Dry Gas Curtain For Cryogenic Surfaces	Europe	Pending		234400/96	1986/10/23
4440	P0055AJP	Standardizing A Spectrometric Instrument	Japan	Pending		97122558.5	1997/12/19
4443	P0056AEP	Standardizing A Spectrometric Instrument	United States	Granted	6,049,762	355500/97	1987/12/22
4443	P0056AJP	Apparatus For Controlling Level Of Cryogenic Liquid	Japan	Pending		08/993,482	1987/12/18
4456	P0057AEP	Apparatus For Controlling Level Of Cryogenic Liquid	Europe	Pending	0851219	3289/1696	1986/12/09
4456	P0057AJP	Standardizing Between Analytical Instruments	Japan	Pending		97122551.1	1997/12/19
4457	P0058AEP	Standardizing Between Analytical Instruments	United States	Pending	0678712	08/883,483	1987/12/18
4457	P0058AJP	Standardizing Of Chromatographic Systems	Europe	Pending		96106041.8	1986/05/18
4457	P0058AEP	Standardizing Of Chromatographic Systems	Japan	Granted	5,958,245	135/33/58	1986/05/18
4458	P0059AJP	Standardizing Of Chromatographic Systems	United States	Pending		09/079,080	1986/05/14
4471	P0062AEP	Heating Control Circuit	Japan	Pending		1082/97	1987/01/08
4471	P0062AJP	Mounting Apparatus For Induction Coupled Plasma Torch	Europe	Granted	0610231	9611/8130.7	1987/01/08
4472	P0063AEP	Mounting Apparatus For Induction Coupled Plasma Torch	Japan	Pending		283630/96	1986/10/15
4472	P0063AJP	Ion Detector, Detector Array And Instrument Using Same	Europe	Pending	0698784	97920359.3	1986/10/23
4472	P0063AEP	Ion Detector, Detector Array And Instrument Using Same	Japan	Pending		9-637249	1986/10/12
4479	P0064AEP	Analyzing Spectrometric Data	Europe	Pending	0834725	87117174.9	1987/10/02
4479	P0064AJP	Analyzing Spectrometric Data	United States	Pending		271050/97	1987/10/03
4484	P0065AEP	Analyzing Spectrometric Data	United States	Granted	6,028,115	08/840,576	1987/09/30
4484	P0065AJP	Self Aligning Optical Fiber Terminator	Japan	Pending		09/285,282	1989/04/02
4493	P0066AEP	Tunable External Cavity Diode Laser	Australia	Pending		40466/97	1997/07/26
4493	P0066AJP	Tunable External Cavity Diode Laser	Canada	Pending		2,261,036	1987/07/26
4498	P0067AEP	Tunable External Cavity Diode Laser	Europe	Pending	0829717	10509031	1987/07/26
4498	P0067AJP	Backflushing System For Gas Chromatography	Japan	Pending		97115655.4	1987/08/09
4531	P0070AEP	Backflushing System For Gas Chromatography	Europe	Pending	0672732	250877/97	1987/08/16
4531	P0070AJP	Method And Apparatus To Compensate For Gas Chromatograph	Japan	Pending		98106622.4	1988/04/15
4538	P0071AEP	Method And Apparatus To Compensate For Gas Chromatograph	United States	Pending		105122/98	1988/04/15
4580	P0072AEP	Autosampler Having Gripper With Shape Memory Metal Actuator	Japan	Pending		60122,892	1989/03/05
4580	P0072AJP	Autosampler Having Gripper With Shape Memory Metal Actuator	United States	Pending		097250,063	1989/03/05
4076	P0073AEP	Absorbance Correction In Atomic Absorption Spectroscopy	Japan	Granted	5,240,784		097250,063
4076	P0073AJP	Computer Control Cable Multi-Port Valve	Japan	Granted	1,361,134		04-346133
3576	P0085AEP	Regulated Deuterium Arc System Supply	Europe	Granted	0254326		1987/01/20
4385	P0045E	Apparatus And Method For Differential Analysis Using Signals	United States	Pending		87110775.1	1987/01/24
4385	P0045A	Apparatus And Method For Differential Analysis Using Signals	United States	Granted	6,549,387	09/065,782	1899/04/23
3934	P0021AEP	3 Point Bending Measuring System	Europe	Granted		08/252,597	1984/06/01
4133	P0030A	Optical Switching Apparatus With Retroreflector	United States	Granted	15,481,631	90120859.5	1984/06/01
4137	P0030A	Grouping Of Spectral Bands For Data Acquisition	United States	Granted	5,412,458	08/201,648	1984/02/25
2495	P0069AJP	Automatic Temperature Calibration Of Thermal Analyzers	Japan	Pending		08/022,515	1983/03/09
3568	P0091A	Deposited Gas Etchers	United States	Granted		22320/60	1980/02/26
4086	P0091A	Photometric Instrument With Optical Fibers For Analyzing	Great Britain	Granted	2,240,026		1984/06/20
4472	P0061AIVO	Ion Detector, Detector Array And Instrument Using Same	PCT	Published		9412352.8	1997/04/11

4433	P0063A	Ion Detector, Detector Array And Instrument Using Same	United States	Pending			09/18/00, 16/7	1998/11/03
2714	P0063B	Tunable External Cavity Diode Laser	United States	Pending			09/23/00, 499	1998/01/26
2714	P0063AEP	Solvent Delivery System	Europe	Granted	0085171	1986/04/13	82111717.3	1992/12/17
2714	P0063AFR	Solvent Delivery System	France	Granted	0085171	1986/04/13	82111717.3	1992/12/17
2714	P0063ADE	Solvent Delivery System	Germany	Granted	P3276327.2	1986/04/13	82111717.3	1992/12/17
2714	P0063AUL	Solvent Delivery System	Netherlands	Granted	0085171	1986/04/13	82111717.3	1992/12/17
2714	P0063AJP	Solvent Delivery System	Italy	Granted	0085171	1986/04/13	82111717.3	1992/12/17
2714	P0063ASE	Solvent Delivery System	Japan	Granted	1,764,707	1993/05/26	11602013	1992/01/28
2714	P0063ACH	Solvent Delivery System	Switzerland	Granted	0085171	1986/04/13	82111717.3	1992/12/17
2714	P0063AGB	Solvent Delivery System	Great Britain	Granted	0085171	1986/04/13	82111717.3	1992/12/17
2714	P0063A	Solvent Delivery System	United States	Granted	4,556,367	1983/12/03	068532,758	1984/07/20
2766	P0064AFR	Spectrophotometer Gas Control System	France	Granted	0069204	1987/09/16		
2766	P0064ACB	Fluid Flow Control Device	Great Britain	Granted	2,085,614	1984/08/30	0125893.1	1981/08/25
2851	P0064ADE	Optical Beam Splitter	Germany	Granted	P3265483.6	1985/08/23	82100548.3	1982/01/29
2851	P0064AJP	Optical Beam Splitter	Japan	Granted	1,792,075	1993/10/14	34115602	1982/03/02
2851	P0064ACH	Optical Beam Splitter	Switzerland	Granted	0059836	1985/08/23	82100548.3	1982/01/29
2851	P0064AGB	Optical Beam Splitter	Great Britain	Granted	0059836	1985/08/23	82100548.3	1982/01/29
2873	P0064ADE	Apparatus Useful With A Chromatography Column	United States	Granted	4,497,477	1984/12/11	06470,427	1981/02/28
2873	P0064ACH	Apparatus Useful With A Chromatography Column	Germany	Granted	P3273842.0	1986/10/15	82106508.1	1992/07/19
2873	P0064AGB	Apparatus Useful With A Chromatography Column	Switzerland	Granted	0075689	1986/10/15	82106508.1	1992/07/19
2772	P0100ADE	Apparatus And Method Useful For Analyzing Refractory Substances	Germany	Granted	3205580	1993/05/13	3205580	1992/07/19
2772	P0100AJP	Apparatus Useful For Analyzing Refractory Substances	Japan	Granted	1,676,561	1992/06/26	227182042	1992/02/16
2780	P0101A	Apparatus Useful For Positioning A Light Filter	United States	Granted	4,400,354	1983/08/23	056235,761	1981/02/19
2876	P0102AEP	Control Circuit For Liquid Chromatograph	Europe	Granted	4,419,575	1983/12/06	056239,305	1981/08/02
2876	P0102AFR	Control Circuit For Liquid Chromatograph	France	Granted	0085172	1987/11/11	82111720.7	1982/12/17
2876	P0102ADE	Control Circuit For Liquid Chromatograph	Germany	Granted	0085172	1987/11/11	82111720.7	1982/12/17
2876	P0102AJP	Control Circuit For Liquid Chromatograph	Italy	Granted	P3277646.9	1987/11/11	82111720.7	1982/12/17
2876	P0102ASE	Control Circuit For Liquid Chromatograph	Sweden	Granted	0085172	1987/11/11	82111720.7	1982/12/17
2876	P0102ACH	Control Circuit For Liquid Chromatograph	Switzerland	Granted	0085172	1987/11/11	82111720.7	1982/12/17
2876	P0102AGB	Control Circuit For Liquid Chromatograph	Great Britain	Granted	0085172	1987/11/11	82111720.7	1982/12/17
2898	P0103AFR	Spectrophotometer	United States	Granted	4,450,574	1984/05/22	087943,805	1982/01/29
2898	P0103ADE	Spectrophotometer	France	Granted	0087664	1987/01/07	83100489.9	1983/01/29
2898	P0103ACH	Spectrophotometer	Germany	Granted	P3368984.9	1987/01/07	83100489.9	1983/01/29
2898	P0103AGB	Spectrophotometer	Great Britain	Granted	0087664	1987/01/07	83100489.9	1983/01/29
2898	P0104AFR	Liquid Level Sensor	United States	Granted	4,464,051	1984/08/07	067354,254	1982/03/02
2898	P0104ADE	Liquid Level Sensor	France	Granted	0729120	1984/08/17	84106522.4	1984/05/30
2898	P0104ACH	Liquid Level Sensor	Germany	Granted	P3473508.7	1984/08/17	84106522.4	1984/05/30
2898	P0104AGB	Liquid Level Sensor	Switzerland	Granted	0729120	1984/08/17	84106522.4	1984/05/30
2991	P0105A	Control Circuit For Stepper Motor	Great Britain	Granted	0129120	1984/08/17	84106522.4	1984/05/30
3007	P0106ADE	L.C. Sample Cell	United States	Granted	4,532,789	1985/08/06	087506,232	1983/06/17
3007	P0106AJP	L.C. Sample Cell	Japan	Granted	4,417,188	1983/11/22	087506,232	1983/06/17
3007	P0106ASE	Sample Cell Temperature Stabilizer	Germany	Granted	3572537.0	1985/05/12	3572537	1984/05/20
3007	P0106ACH	Sample Cell Temperature Stabilizer	Switzerland	Granted	0154792	1989/08/23	85100841.2	1985/11/30
3007	P0106AGB	Sample Cell Temperature Stabilizer	United States	Granted	0154792	1989/08/23	85100841.2	1985/11/30
3007	P0106A	Sample Cell Temperature Stabilizer	Great Britain	Granted	0154792	1989/08/23	85100841.2	1985/11/30
3048	P0108AJP	Formose Positioning Mechanism	Australia	Granted	4,598,765	1986/07/09	064576,545	1984/02/03
3048	P0108ADE	Formose Positioning Mechanism	United States	Granted	P3376594.5	1984/11/20	83107709.4	1983/08/04
3048	P0108ACH	Formose Positioning Mechanism	Germany	Granted	0101862	1984/11/20	83107709.4	1983/08/04
3048	P0108AGB	Formose Positioning Mechanism	Italy	Granted	0101862	1984/11/20	83107709.4	1983/08/04
3061	P0110AEP	The Use Of Thin Driven Soda Glass Coated To Protect From Contact	Great Britain	Granted	0133226	1988/03/30	84100020.6	1984/07/19

3061	P0110ABE	SIP Clutch Assembly	Belgium	Granted	0,133,226	1988/03/30	84108028.6	1984/7/9
3061	P0110AFR	SIP Clutch Assembly	France	Granted	0133226	1988/03/30	84108028.6	1984/7/9
3061	P0110ADE	Coupler Mechanism	Germany	Granted	3470189.0	1988/03/30	84108028.6	1984/7/9
3061	P0110ANL	SIP Clutch Assembly	Netherlands	Granted	0133226	1988/03/30	84108028.6	1984/7/9
3061	P0110ANT	SIP Clutch Assembly	Italy	Granted	0133226	1988/03/30	84108028.6	1984/7/9
3061	P0110ACH	SIP Clutch Assembly	Switzerland	Granted	0133226	1988/03/30	84108028.6	1984/7/9
3061	P0110A	SIP Clutch Assembly	United States	Granted	4,360,050	1988/03/30	84108028.6	1984/7/9
3076	P0111AEP	Spectrophotometer	Europe	Granted	0135761	1991/08/05	84108050.0	1984/08/09
3076	P0111ABE	Spectrophotometer	Belgium	Granted	0135761	1991/08/05	84108050.0	1984/08/09
3076	P0111AFR	Spectrophotometer	France	Granted	0135761	1991/08/05	84108050.0	1984/08/09
3076	P0111ADE	Optical Design Of Fourier Transform Spectrophotometer	Germany	Granted	P3484868.9	1991/08/05	84108050.0	1984/08/09
3076	P0111ANL	Spectrophotometer	Netherlands	Granted	0135761	1991/08/05	84108050.0	1984/08/09
3076	P0111ANT	Spectrophotometer	Italy	Granted	0135761	1991/08/05	84108050.0	1984/08/09
3076	P0111AJP	Optical Design Of Fourier Transform Spectrophotometer	Japan	Granted	1,800,723	1993/11/12	84108050.0	1984/08/09
3076	P0111ACH	Spectrophotometer	Switzerland	Granted	0135761	1991/08/05	84108050.0	1984/08/09
3076	P0111AGB	Spectrophotometer	Great Britain	Granted	0135761	1991/08/05	84108050.0	1984/08/09
3076	P0111A	Spectrophotometer	United States	Granted	4,740,082	1991/08/05	84108050.0	1984/08/09
3101	P0111ZA	Solvent Pressurizing System	United States	Granted	4,448,684	1994/03/15	84108050.0	1984/08/09
3109	P01113A	Liquid Chromatography Controller	United States	Granted	4,618,835	1995/10/21	84108050.0	1984/08/09
3111	P01114A	Pulse Damper	United States	Granted	4,548,713	1995/10/22	84108050.0	1984/08/09
3111	P01114ADE	RTV Pulse Damper	Germany	Granted	3585429.5	1998/10/06	3585429.5	1984/10/05
3111	P01114AJP	RTV Pulse Damper	Japan	Granted				
3111	P01114ASE	Pulse Damper	Sweden	Granted	0158132	1998/10/06	85101252.8	1985/02/06
3111	P01114ACH	Pulse Damper	Switzerland	Granted	0158132	1998/10/06	85101252.8	1985/02/06
3111	P01114AGB	Pulse Damper	Great Britain	Granted	0158132	1998/10/06	85101252.8	1985/02/06
3138	P0118AAU	Holder Assembly For Reaction Tubes	Australia	Allowed	705,789	1993/09/27	1993/09/27	1994/02/11
3139	P0117AAU	ICP Bad Plasma Detector	Australia	Allowed	705,789	1993/09/27	1993/09/27	1994/02/11
3135	P0115AEP	Instantaneous Reading Multichannel Polychromatic Spectrophot	Europe	Granted	0182200	1996/03/06	86101901.6	1986/02/14
3135	P0115AFR	Instantaneous Reading Multichannel Polychromatic Spectrophot	France	Granted	0192200	1994/03/06	86101901.6	1986/02/14
3135	P0115ADE	A Novel Army Spectrometer	Germany	Granted	3850491.2	1996/03/06	3850491.2	1996/03/06
3135	P0115ANL	Instantaneous Reading Multichannel Polychromatic Spectrophot	Netherlands	Granted	0192200	1996/03/06	86101901.6	1986/02/14
3135	P0115AJP	A Novel Army Spectrometer	Japan	Granted	2,602,809	1997/01/29		
3135	P0115ACH	Instantaneous Reading Multichannel Polychromatic Spectrophot	Switzerland	Granted	0192200	1996/03/06	86101901.6	1986/02/14
3135	P0115AGB	Instantaneous Reading Multichannel Polychromatic Spectrophot	Great Britain	Granted	0192200	1996/03/06	86101901.6	1986/02/14
3135	P0115A	Instantaneous Reading Multichannel Polychromatic Spectrophot	United States	Granted	4,676,817	1997/07/07	86101901.6	1986/02/14
3138	P0116ADE	Holder Assembly For Reaction Tubes	Germany	Granted	3407085	1994/12/22	3407085	1994/02/27
3138	P0116AJP	Holder Assembly For Reaction Tubes	Japan	Granted	1,919,140	1995/04/07	3548804	1994/02/27
3138	P0116A	Holder Assembly For Reaction Tubes	United States	Granted	6,032,283	1997/07/15	061862,017	1994/02/27
3138	P0117A	Apparatus For Monitoring A Plasma Torch	United States	Granted	4,640,827	1997/02/03	061862,758	1994/02/27
3142	P0118AEP	An Apparatus And Method For Optimizing Separation Of An Unkn	Europe	Granted	0175925	1992/09/30	85110513.0	1985/08/21
3142	P0118AFR	An Apparatus And Method For Optimizing Separation Of An Unkn	France	Granted	0175925	1992/09/30	85110513.0	1985/08/21
3142	P0118ADE	An Apparatus And Method For Optimizing The Separation Of An Un	Germany	Granted	P3506705.1	1992/09/30	85110513.0	1985/08/21
3142	P0118ANL	An Apparatus And Method For Optimizing The Separation Of An Un	Netherlands	Granted	0175925	1992/09/30	85110513.0	1985/08/21
3142	P0118AJP	An Apparatus And Method For Optimizing The Separation Of An Un	Japan	Granted	2,075,811	1996/07/25	1596/07/25	1996/07/25
3142	P0118ACH	An Apparatus And Method For Optimizing Separation Of An Unkn	Switzerland	Granted	0175925	1992/09/30	85110513.0	1985/08/21
3142	P0118AGB	An Apparatus And Method For Optimizing Separation Of An Unkn	Great Britain	Granted	0175925	1992/09/30	85110513.0	1985/08/21
3142	P0118A	Apparatus And Method For Optimizing Separation Of A Sample	United States	Granted	4,579,653	1988/04/01	061863,256	1984/08/21
3143	P0119A	Production Of Flexible Glass Capillary Tubing Without Extern	United States	Granted				
3162	P0120A	Light Detector Apparatus	United States	Granted	5,073,345	1991/12/17	061753,370	1993/07/08
3173	P0121A	Sample Cell Temperature Stabilizer	United States	Granted	4,589,477	1988/03/30	84108028.6	1984/7/9
3173	P0121AEP	Compensator Plate Adjustment For Beam Splitter	Europe	Granted	0137206	1991/01/23	84109507.8	1994/08/09
3173	P0121ABE	Compensator Plate Adjustment For Beam Splitter	Belgium	Granted	0137206	1991/01/23	84109507.8	1994/08/09
3173	P0121AFR	Compensator Plate Adjustment For Beam Splitter	France	Granted	0137206	1991/01/23	84109507.8	1994/08/09
3173	P0121ADE	Compensator Plate Adjustment For Beam Splitter	Germany	Granted	P3483982.5	1991/01/23	84109507.8	1994/08/09
3173	P0121ANL	Compensator Plate Adjustment For Beam Splitter	Netherlands	Granted	0137206	1991/01/23	84109507.8	1994/08/09
3173	P0121AJP	Compensator Plate Adjustment For Beam Splitter	Japan	Granted	0137206	1991/01/23	84109507.8	1994/08/09

3173	P0123AUP	Compensator Plate Adjustment For Beam Splitter	Japan	Granted	2,131,945	1986/04/12		
3173	P0123AGH	Compensator Plate Adjustment For Beam Splitter	Japan	Granted	2,131,945	1986/04/12		
3173	P0123AGB	Compensator Plate Adjustment For Beam Splitter	Great Britain	Granted	0,137,206	1981/10/123	84,109,507.8	1984/08/09
3175	P0123ABE	Assembly For Adjusting An Optical Element	United States	Granted	4,735,505	1981/10/123	84,109,507.8	1984/08/09
3175	P0123ADE	Purge Shutter Mechanism	Belgium	Granted	0,144,539	1981/04/05	08,527,885	1983/06/28
3175	P0123AHL	Purge Shutter Mechanism	Germany	Granted	34,783,13	1981/04/08		
3175	P0123AJT	Purge Shutter Mechanism	Netherlands	Granted	0,144,539	1981/04/08		
3175	P0123AJP	Purge Shutter Mechanism	Italy	Granted	0,144,539	1981/04/08		
3175	P0123ACH	Purge Shutter Mechanism	Japan	Granted	0,144,539	1981/04/08		
3178	P0123AEP	Purge Shutter Mechanism	Switzerland	Granted	1,772,551	1981/07/14		
3178	P0123AFR	Digital Control For Rapid Refill Of A Liquid Chromatograph	United States	Granted	0,144,539	1981/08/09		
3178	P0123AFR	Digital Control For Rapid Refill Of A Liquid Chromatograph	Europe	Granted	4,603,835	1981/08/05	08,540,952	1983/11/08
3178	P0123ADE	Digital Control For Rapid Refill Of A Liquid Chromatograph	France	Granted	0,194,450	1981/10/123	85,101,623	1981/02/07
3178	P0123ANL	Digital Control For Rapid Refill Of A Liquid Chromatograph	Germany	Granted	0,194,450	1981/10/123		
3178	P0123AJT	Digital Control For Rapid Refill Of A Liquid Chromatograph	Netherlands	Granted	36,770,29	1981/10/123		
3178	P0123AJP	Digital Control For Rapid Refill Of A Liquid Chromatograph	Italy	Granted	0,194,450	1981/10/123		
3178	P0123ASE	Digital Control For Rapid Refill Of A Liquid Chromatograph	Japan	Granted	1,973,685	1981/10/17		
3178	P0123AGH	Digital Control For Rapid Refill Of A Liquid Chromatograph	Sweden	Granted	0,194,450	1981/10/123		
3178	P0123AGB	Digital Control For Rapid Refill Of A Liquid Chromatograph	Switzerland	Granted	0,194,450	1981/10/123		
3178	P0123A	Digital Control For Rapid Refill Of A Liquid Chromatograph	Great Britain	Granted	0,194,450	1981/10/123		
3196	P0126AEP	Interferometer Mirror Adjustment	United States	Granted	4,643,649	1987/02/17	06,700,765	1985/02/11
3196	P0126AFR	Interferometer Mirror Adjustment	Europe	Granted	0,158,173	1981/11/02	85,103,202	1985/03/18
3196	P0126ADE	Interferometer Mirror Adjustment	France	Granted	0,158,173	1981/11/02		
3196	P0126AJP	Interferometer Mirror Adjustment	Germany	Granted	0,158,173	1981/11/02		
3196	P0126AGB	Interferometer Mirror Adjustment	Japan	Granted	0,158,173	1981/11/02		
3196	P0126A	Interferometer Mirror Adjustment	Great Britain	Granted	0,158,173	1981/11/02		
3213	P0128AEP	Micro Argon Detector	United States	Granted	4,621,899	1986/11/11	06,598,768	1984/01/08
3213	P0128AFR	Micro Argon Detector	Europe	Granted	0,184,882	1982/08/19	85,305,185.9	1985/07/22
3213	P0128ADE	Micro Argon Detector	France	Granted	0,184,882	1982/08/19	85,305,185.9	1985/07/22
3213	P0128ANL	Micro Argon Detector	Germany	Granted	0,184,882	1982/08/19	85,305,185.9	1985/07/22
3213	P0128AJP	Micro Argon Detector	Netherlands	Granted	0,184,882	1982/08/19	85,305,185.9	1985/07/22
3213	P0128AGH	Micro Argon Detector	Japan	Granted	1,893,498	1983/01/23	1985/12/13	
3213	P0128AGB	Micro Argon Detector	Switzerland	Granted	0,184,882	1982/08/19	85,305,185.9	1985/07/22
3234	P0128A	Micro Argon Detector	Great Britain	Granted	0,184,882	1982/08/19	85,305,185.9	1985/07/22
3234	P0128A	Micro Argon Detector	United States	Granted	4,740,895	1986/04/26	06,781,553	1985/10/15
3235	P0130AEP	Apparatus For Controlling A Plasma	United States	Granted	4,602,810	1986/08/02	06,624,313	1984/06/28
3235	P0130AFR	Liquid Chromatographic Cartridge Column System	Europe	Granted	0,161,493	1982/05/20	84,104,441	1985/04/12
3235	P0130ADE	Liquid Chromatographic Cartridge Column System	France	Granted	0,161,493	1982/05/20	84,104,441.2	1985/04/12
3235	P0130ANL	Liquid Chromatographic Cartridge Column System	Germany	Granted	0,161,493	1982/05/20	84,104,441.2	1985/04/12
3235	P0130AJP	Liquid Chromatographic Cartridge Column System	Netherlands	Granted	0,161,493	1982/05/20	84,104,441.2	1985/04/12
3235	P0130ACH	Liquid Chromatographic Cartridge Column System	Japan	Granted	2,574,045	1983/01/27	1,585,94	1985/05/07
3235	P0130AGB	Liquid Chromatographic Cartridge Column System	Switzerland	Granted	0,161,493	1982/05/20	84,104,441.2	1985/04/12
3235	P0130A	Liquid Chromatographic Cartridge Column System	Great Britain	Granted	0,161,493	1982/05/20	84,104,441.2	1985/04/12
3236	P023AEP	Polymerization For Multi-Element Analysis	United States	Granted	4,587,014	1986/05/06	06,630,878	1984/05/07
3236	P023AFR	Polymerization For Multi-Element Analysis	Europe	Granted	0,282,043	1983/10/20		
3236	P023ADE	Polymerization For Multi-Element Analysis	France	Granted	0,282,043	1983/10/20		
3236	P023ANL	Polymerization For Multi-Element Analysis	Germany	Granted	0,282,043	1983/10/20		
3236	P023AJP	Polymerization For Multi-Element Analysis	Italy	Granted	0,282,043	1983/10/20		
3236	P023ACH	Polymerization For Multi-Element Analysis	Japan	Granted	0,282,043	1983/10/20		
3236	P023AGB	Polymerization For Multi-Element Analysis	Switzerland	Granted	0,282,043	1983/10/20		
3236	P023A	Polymerization For Multi-Element Analysis	Great Britain	Granted	0,282,043	1983/10/20		
3238	P0131AEP	Dual Servo Impedance Matching System For Icp Spectroscopy	United States	Granted	4,785,257	1989/01/03	07,024,237	1987/03/10
3238	P0131AFR	Dual Servo Impedance Matching System For Icp Spectroscopy	Europe	Granted	0,155,496	1989/10/102		
3238	P0131ADE	Dual Servo Impedance Matching System For Icp Spectroscopy	France	Granted	0,155,496	1989/10/102		
3238	P0131ANL	Dual Servo Impedance Matching System For Icp Spectroscopy	Germany	Granted	0,155,496	1989/10/102		
3238	P0131AJP	Dual Servo Impedance Matching System For Icp Spectroscopy	Italy	Granted	0,155,496	1989/10/102		
3238	P0131ACH	Dual Servo Impedance Matching System For Icp Spectroscopy	Japan	Granted	0,155,496	1989/10/102		
3238	P0131AGB	Dual Servo Impedance Matching System For Icp Spectroscopy	Switzerland	Granted	0,155,496	1989/10/102		
3238	P0131A	Dual Servo Impedance Matching System For Icp Spectroscopy	Great Britain	Granted	0,155,496	1989/10/102		
3238	P024AEP	Plasma Emission Source	United States	Granted	5,108,187	1992/04/28	07,722,393	1991/06/18
3238	P024AFR	Plasma Emission Source	Europe	Granted	0,155,496	1989/10/102		
3238	P024ADE	Plasma Emission Source	France	Granted	0,155,496	1989/10/102		
3238	P024ANL	Plasma Emission Source	Germany	Granted	0,155,496	1989/10/102		
3238	P024AJP	Plasma Emission Source	Italy	Granted	0,155,496	1989/10/102		
3238	P024ACH	Plasma Emission Source	Japan	Granted	0,155,496	1989/10/102		
3238	P024AGB	Plasma Emission Source	Switzerland	Granted	0,155,496	1989/10/102		
3238	P024A	Plasma Emission Source	Great Britain	Granted	0,155,496	1989/10/102		
3238	P024A	Plasma Emission Source	United States	Granted	5,108,187	1992/04/28	07,722,393	1991/06/18
3238	P024A	Plasma Emission Source	Europe	Granted	0,155,496	1989/10/102		
3238	P024A	Plasma Emission Source	France	Granted	0,155,496	1989/10/102		
3238	P024A	Plasma Emission Source	Germany	Granted	0,155,496	1989/10/102		
3238	P024A	Plasma Emission Source	Italy	Granted	0,155,496	1989/10/102		
3238	P024A	Plasma Emission Source	Japan	Granted	0,155,496	1989/10/102		
3238	P024A	Plasma Emission Source	Switzerland	Granted	0,155,496	1989/10/102		
3238	P024A	Plasma Emission Source	Great Britain	Granted	0,155,496	1989/10/102		
3238	P024A	Plasma Emission Source	United States	Granted	5,108,187	1992/04/28	07,722,393	1991/06/18
3238	P024A	Plasma Emission Source	Europe	Granted	0,155,496	1989/10/102		
3238	P024A	Plasma Emission Source	France	Granted	0,155,496	1989/10/102		
3238	P024A	Plasma Emission Source	Germany	Granted	0,155,496	1989/10/102		
3238	P024A	Plasma Emission Source	Italy	Granted	0,155,496	1989/10/102		
3238	P024A	Plasma Emission Source	Japan	Granted	0,155,496	1989/10/102		
3238	P024A	Plasma Emission Source	Switzerland	Granted	0,155,496	1989/10/102		
3238	P024A	Plasma Emission Source	Great Britain	Granted	0,155,496	1989/10/102		
3238	P024A	Plasma Emission Source	United States	Granted	5,108,187	1992/04/28	07,722,393	1991/06/18
3238	P024A	Plasma Emission Source	Europe	Granted	0,155,496	1989/10/102		
3238	P024A	Plasma Emission Source	France	Granted	0,155,496	1989/10/102		
3238	P024A	Plasma Emission Source	Germany	Granted	0,155,496	1989/10/102		
3238	P024A	Plasma Emission Source	Italy	Granted	0,155,496	1989/10/102		
3238	P024A	Plasma Emission Source	Japan	Granted	0,155,496	1989/10/102		
3238	P024A	Plasma Emission Source	Switzerland	Granted	0,155,496	1989/10/102		
3238	P024A	Plasma Emission Source	Great Britain	Granted	0,155,496	1989/10/102		
3238	P024A	Plasma Emission Source	United States	Granted	5,108,187	1992/04/28	07,722,393	1991/06/18
3238	P024A	Plasma Emission Source	Europe	Granted	0,155,496	1989/10/102		
3238	P024A	Plasma Emission Source	France	Granted	0,155,496	1989/10/102		
3238	P024A	Plasma Emission Source	Germany	Granted	0,155,496	1989/10/102		
3238	P024A	Plasma Emission Source	Italy	Granted	0,155,496	1989/10/102		
3238	P024A	Plasma Emission Source	Japan	Granted	0,155,496	1989/10/102		
3238	P024A	Plasma Emission Source	Switzerland	Granted	0,155,496	1989/10/102		
3238	P024A	Plasma Emission Source	Great Britain	Granted	0,155,496	1989/10/102		
3238	P024A	Plasma Emission Source	United States	Granted	5,108,187	1992/04/28	07,722,393	1991/06/18
3238	P024A	Plasma Emission Source	Europe	Granted	0,155,496	1989/10/102		
3238	P024A	Plasma Emission Source	France	Granted	0,155,496	1989/10/102		
3238	P024A	Plasma Emission Source	Germany	Granted	0,155,496	1989/10/102		
3238	P024A	Plasma Emission Source	Italy	Granted	0,155,496	1989/10/102		
3238	P024A	Plasma Emission Source	Japan	Granted	0,155,496	1989/10/102		
3238	P024A	Plasma Emission Source	Switzerland	Granted	0,155,496	1989/10/102		
3238	P024A	Plasma Emission Source	Great Britain	Granted	0,155,496	1989/10/102		
3238	P024A	Plasma Emission Source	United States	Granted	5,108,187	1992/04/28	07,722,393	1991/06/18
3238	P024A	Plasma Emission Source	Europe	Granted	0,155,496	1989/10/102		
3238	P024A	Plasma Emission Source	France	Granted	0,155,496	1989/10/102		
3238	P024A	Plasma Emission Source	Germany	Granted	0,155,496	1989/10/102		
3238	P024A	Plasma Emission Source	Italy	Granted	0,155,496	1989/10/102		
3238	P024A	Plasma Emission Source	Japan	Granted	0,155,496	1989/10/102		
3238	P024A	Plasma Emission Source	Switzerland	Granted	0,155,496	1989/10/102		
3238	P024A	Plasma Emission Source	Great Britain	Granted	0,155,496	1989/10/102		
3238	P024A	Plasma Emission Source	United States	Granted	5,108,187	1992/04/28	07,722,393	1991/06/18
3238	P024A	Plasma Emission Source	Europe	Granted	0,155,496	1989/10/102		
3238	P024A	Plasma Emission Source	France	Granted	0,155,496	1989/10/102		
3238	P024A	Plasma Emission Source	Germany	Granted	0,155,496	1989/10/102		
3238	P024A	Plasma Emission Source	Italy	Granted	0,155,496	1989/10/102		
3238	P024A	Plasma Emission Source	Japan	Granted	0,155,496	1989/10/102		
3238	P024A	Plasma Emission Source	Switzerland	Granted	0,155,496	1989/10/102		
3238	P024A	Plasma Emission Source	Great Britain	Granted	0,155,496	1989/10/102		
3238	P024A	Plasma Emission Source	United States	Granted	5,108,187	1992/04/28	07,722,393	1991/06/18
3238	P024A	Plasma Emission Source	Europe	Granted	0,155,496	1989/10/102		
3238	P024A	Plasma Emission Source	France	Granted	0,155,496	1989/10/102		
3238	P024A	Plasma Emission Source	Germany	Granted	0,155,496	1989/10/102		
3238	P024A	Plasma Emission Source	Italy	Granted	0,155,496	1989/10/102		
3238	P024A	Plasma Emission Source	Japan	Granted	0,155,496	1989/10/102		
3238	P024A	Plasma Emission Source	Switzerland	Granted	0,155,496	1989/10/102		
3238	P024A	Plasma Emission Source	Great Britain	Granted	0,155,496	1989/10/102		
3238	P024A	Plasma Emission Source	United States	Granted	5,108,187	1992/04/28	07,722,393	1991/06/18
3238	P024A	Plasma Emission Source	Europe	Granted	0,155,496	1989/10/102		
3238	P024A	Plasma Emission Source	France					

4314	P0245ADE	Connection Of Spectra For Slury Radiation	Germany	Granted	684,122/21.1	1989/04/05		
3289	P0132AEP	Multiple Streams Sampling System	Europe	Granted	0154106	1891/06/25		
4314	P0245AJP	Connection Of Spectra For Slury Radiation	Japan	Granted	0154106	1891/06/25		
3289	P0132ADE	Multiple Streams Sampling System	Germany	Pending	3584175.3	1981/09/25	3136898/4	1994/12/16
3289	P0132ASE	Multiple Streams Sampling System	Sweden	Granted	0154106	1991/09/25		
4314	P0245AGB	Connection Of Spectra For Slury Radiation	Great Britain	Granted	0658751	1888/04/05	8411807/6.4	1994/12/15
3289	P0132ACH	Multiple Streams Sampling System	Switzerland	Granted	0154106	1991/09/25		
4314	P0245A	Connection Of Spectra For Slury Radiation	United States	Granted	5,428,558	1995/06/27	09/186,000	1993/12/17
3289	P0132A	Apparatus For Periodically Monitoring Composition of Samples	United States	Granted	4,670,659	1987/07/07	064585,787	1994/03/02
3289	P0132A	Synchronous Wavelength Drive And Data Acquisition Conversion	United States	Granted	4,960,977	1987/04/29	066704,344	1985/02/22
3289	P0132A	Safety Apparatus For an Atomic Absorption Spectroscopy Burner	United States	Granted	4,568,267	1986/02/04	066707,711	1984/11/13
3289	P0132A	Self-Sprung Lampholder	United States	Granted	4,597,034	1986/06/24	066707,715	1984/11/13
3289	P0132AEP	Programmed Temperature Control Of A Thermal System	Europe	Granted	0184283	1991/12/04	85305195.1	1985/07/22
3289	P0132AEP	Programmed Temperature Control Of A Thermal System	France	Granted	0184283	1991/12/04	85305195.1	1985/07/22
3289	P0132ADE	Programmed Temperature Control Of A Thermal System	Germany	Granted	0184283	1991/12/04	85305195.1	1985/07/22
3289	P0132ADE	Programmed Temperature Control Of A Thermal System	Netherlands	Granted	0184283	1991/12/04	85305195.1	1985/07/22
3289	P0132AJP	Programmed Temperature Control Of A Thermal System	Japan	Granted	2,033,583	1996/03/18	77238195.1	1985/07/22
3289	P0132AJP	Programmed Temperature Control Of A Thermal System	Switzerland	Granted	0184283	1991/12/04	85305195.1	1985/07/22
3289	P0132AGB	Programmed Temperature Control Of A Thermal System	Great Britain	Granted	0184283	1991/12/04	85305195.1	1985/07/22
3289	P0132A	Programmed Temperature Control Of A Thermal System	United States	Granted	4,752,218	1984/06/21	06630,582	1985/11/13
3289	P0132A	Ionization Detectors For Gas Chromatography	United States	Granted	4,641,441	1983/06/06	066322,585	1984/10/24
3289	P0132A	Ionization Detectors For Gas Chromatography	Great Britain	Granted	2,103,897	1980/07/11	8526865.6	1985/10/20
3289	P0132A	Linearized Ultra-Low Noise Mic Preamp	Germany	Granted	3605488	1995/05/24	3606488	1986/02/20
3289	P0132A	Detector Preamp/Filter For Use with a MIC Detector	Great Britain	Granted	2,068,543	1996/07/10	354038/6	1986/02/21
3289	P0132A	Fluid Flow Control System	United States	Granted	2,171,512	1989/01/25	6601998.9	1986/01/28
3289	P0256AJP	Optical Beam Switching Apparatus	United States	Granted	4,682,022	1987/07/21	066704,355	1985/02/21
3289	P0256AJP	Optical Beam Switching Apparatus	Germany	Granted	4,617,853	1986/10/21	066707,714	1984/11/13
3289	P0256AJP	Optical Beam Switching Apparatus	Italy	Granted	12282145	1987/09/10	2028145	1976/06/27
3289	P0256AJP	System for Changing Oxidants in a Spectrophotometer	Great Britain	Granted	1151527	1986/02/03		
3289	P0256AJP	Phase Synchronization	United States	Granted	1539348	1978/05/30		
3289	P0256AJP	Spectroscopic Phase Synchronization Apparatus	Japan	Granted	4,571,172	1986/02/16	066707,713	1984/11/13
3289	P0256AJP	Method And Apparatus For Determining The Nature Of An Unknown	Great Britain	Granted	1,711,151	1992/11/11	9624082	1984/01/26
3289	P0256AJP	Apparatus And Method For Determining The Nature Of An Unknown	United States	Granted	2,092,208	1984/04/22	8131707.5	1984/10/21
3289	P01013AU	Apparatus Useful For Positioning A Light Filter	Japan	Granted	4,368,852	1983/06/07	066229,083	1981/01/29
3289	P0240AEP	Solvent Pressurizing & Degassing System	Great Britain	Granted	1,670,092	1992/06/12	1675381	1981/02/06
3289	P0240AEP	Solvent Pressurizing & Degassing System	Australia	Granted	2,070,235	1984/02/01	8103068.4	1981/02/02
3289	P0240AEP	Electro-Optical Ion Detector For A Scanning Mass Spectrometer	France	Granted	384,477	1865/12/12	8457182	1982/06/01
3289	P0144ADE	Solvent Pressurizing & Degassing System	Europe	Pending	0179349	1989/05/24		
3289	P0144ADE	Solvent Pressurizing & Degassing System	Germany	Granted	3570527.2	1989/05/24	90101324.3	1990/01/23
3289	P0144ADE	Solvent Pressurizing & Degassing System	Netherlands	Granted	0179349	1989/05/24	3570527	1989/05/24
3289	P0144ADE	Solvent Pressurizing & Degassing System	Switzerland	Granted	0179349	1989/05/24		
3289	P0144ADE	Solvent Pressurizing & Degassing System	Great Britain	Granted	0179349	1989/05/24		
3289	P0144ADE	Solvent Pressurizing & Degassing System	United States	Granted	4,541,452	1985/06/17	06659,374	1984/10/10
3289	P0144ADE	Electro-Optical Ion Detector For A Scanning Mass Spectrometer	Japan	Pending	3,063,832	2000/04/07	3654390	1990/01/16
3289	P0144ADE	Ionization Detectors For Gas Chromatography	Europe	Granted	0249714	1992/06/17	87105713.9	1987/04/16
3289	P0144ADE	Ionization Detectors For Gas Chromatography	France	Granted	0249714	1992/06/17	87105713.9	1987/04/16
3289	P0144ADE	Ionization Detectors For Gas Chromatography	Germany	Granted	0249714	1992/06/17	87105713.9	1987/04/16
3289	P0144ADE	Electro-Optical Ion Detector For A Scanning Mass Spectrometer	Netherlands	Granted	0249714	1992/06/17	87105713.9	1987/04/16
3289	P0144ADE	Ionization Detectors For Gas Chromatography	Canada	Granted	2,007,782	2000/01/14	2,007,782	1980/01/15
3289	P0144ADE	Ionization Detectors For Gas Chromatography	Italy	Granted	0249714	1992/06/17	87105713.9	1987/04/16
3289	P0144ADE	Ionization Detectors For Gas Chromatography	Japan	Granted	2,574,288	1988/10/24		
3289	P0144ADE	Ionization Detectors For Gas Chromatography	Sweden	Granted	0249714	1992/06/17	87105713.9	1987/04/16
3289	P0144ADE	Ionization Detectors For Gas Chromatography	Great Britain	Granted	0249714	1992/06/17	87105713.9	1987/04/16
3289	P0144ADE	Ionization Detectors For Gas Chromatography	United States	Granted	4,873,662	1989/10/17	07004,910	1987/01/09
3289	P0042AAU	Ionization Detectors For Gas Chromatography	Australia	Granted	707,363	1999/07/08	25011195	1995/07/14

3369	P0146AEP	Automatic Optimization Procedure	Europe	Granted	0192201	1992/07/29	6344/96	1996/02/20
3369	P0146AAU	Automatic Optimization Procedure	Australia	Granted	586,853	1989/07/27	5344/96	1996/02/20
3369	P0146ACA	Automatic Optimization Procedure	Canada	Granted	1,271,342	1990/07/10	500,841	1995/01/31
3369	P0146ADE	Automatic Optimization Procedure	Germany	Granted	3586175.8	1992/07/29		
3369	P0146ANL	Automatic Optimization Procedure	Netherlands	Granted	0192201	1992/07/29		
3369	P0146AAT	Automatic Optimization Procedure	Italy	Granted	0192201	1992/07/29		
3369	P0146AJP	Automatic Optimization Procedure	Japan	Granted	1,911,192	1993/03/09	35408/85	1996/02/21
3369	P0146ACH	Automatic Optimization Procedure	Switzerland	Granted	0192201	1993/07/29		
3369	P0146A	Automatic Absorption Spectrometer	Australia	Granted	4,689,764	1987/08/25	068704,355	1995/02/21
3369	P0199AAU	Automatic Absorption Spectrometer	United States	Granted	502,261	1993/03/16	60858/85	1996/04/07
3369	P0199A	Automatic Absorption Spectrometer	United States	Granted	2,118,078	1989/12/05		
3369	P0200AJP	Gas Control Device For Controlling The Fuel Gas	United States	Granted	4,991,960	1993/02/12	06893,766	1996/04/06
3369	P0147A	Gas Control Device For Controlling The Fuel Gas	Japan	Granted	2,016,021	1989/02/19	191781/86	1996/04/17
3369	P0203A	Burner Assembly For Atomic Absorption Spectrometer	United States	Granted	4,689,324	1993/05/02	06853,263	1996/04/17
3369	P0147AJP	Electro-Optical Ion Detector For A Scanning Mass Spectrometer	United States	Granted	4,776,634	1993/01/11	068932,957	1996/11/19
3369	P0175A	Electro-Optical Ion Detector For A Scanning Mass Spectrometer	United States	Granted	5,065,621	1993/10/01	07616,123	1997/11/19
3369	P0262A	Electrothermal Atomization Furnace For Spectroscopy	United States	Granted	4,917,493	1993/04/17	07205,888	1998/06/13
3369	P0018A	Synchronization Of Digital Signals With Alternating Current	United States	Granted	4,861,207	1990/10/02	07388,150	1993/04/02
3369	P0023A	Pump/Injector Mechanism For Use In Chromatography	United States	Granted	5,360,596	1996/11/01	07504,626	1997/04/05
3369	P0031A	Single Element Thermal Conductivity Detector	United States	Granted	5,265,459	1993/11/20	07748,588	1997/04/22
3369	P0025A	Circuit For Heating And Sensing With A Single Element	United States	Granted	5,099,199	1992/03/24	07637,392	1997/10/04
3369	P0261AAU	Optical Coupling Device	Australia	Granted	562,372	1995/02/21	76372/81	1997/10/20
3369	P0261ADE	Optical Coupling Device	Germany	Granted	3,759,327	1997/02/25	3175932	1997/02/25
3369	P0261ACH	Optical Coupling Device	Switzerland	Granted	005,1192	1997/02/25		
3369	P0027A	Standardizing And Calibrating A Spectrometric Instrument	United States	Granted	5,303,165	1994/04/12	07184,448	1997/02/12
3369	P0041A	Hybrid Vialing System For Varying Fluid Flow Rate	United States	Granted	5,329,985	1994/07/19	08100,596	1997/07/20
3369	P0044A	Optical Spectrometer For Detecting Spectra In Separate Range	United States	Granted	5,565,983	1995/10/15	08451,351	1998/05/26
3369	P0042A	Nebulizer	United States	Granted	5,464,157	1995/11/07	08276,144	1994/07/18
3369	P0043B	Spark Sampling Microparticle Generator And Method	United States	Granted	5,452,089	1995/09/19	08137,054	1998/10/15
3369	P0021A	3 Point Bending Measuring System	United States	Granted	4,976,152	1990/12/11	07343,114	1998/11/13
3369	P0024C	Vial Loader And Sensor	United States	Granted	5,171,530	1992/12/15	07203,689	1997/12/03
3369	P0064AEP	Integral Separation Capillary/Conductivity Detector	Europe	Granted	0241940	1993/01/27	87105712.1	1997/04/06
3369	P0064AFR	Integral Separation Capillary/Conductivity Detector	France	Granted	0241940	1993/01/27	87105712.1	1997/04/16
3369	P0064ADE	Integral Separation Capillary/Conductivity Detector	Germany	Granted	0241940	1993/01/27	87105712.1	1997/04/16
3369	P0064ANL	Integral Separation Capillary/Conductivity Detector	Netherlands	Granted	0241940	1993/01/27	87105712.1	1997/04/16
3369	P0064AAT	Integral Separation Capillary/Conductivity Detector	Italy	Granted	0241940	1993/01/27	87105712.1	1997/04/16
3369	P0064AJP	Integral Separation Capillary/Conductivity Detector	Japan	Granted	2,735,545	1993/01/27		
3369	P0064ASE	Integral Separation Capillary/Conductivity Detector	Sweden	Granted	0241940	1993/01/27	87105712.1	1997/04/16
3369	P0064AGB	Integral Separation Capillary/Conductivity Detector	Great Britain	Granted	0241940	1993/01/27	87105712.1	1997/04/16
3369	P0064A	Method of Fabricating Capillary/Conductivity Detector	United States	Granted	4,616,123	1988/03/28	07031,808	1997/07/06
3369	P0267A	Grasping Finger Position Sensor For A Robot System	United States	Granted	4,682,905	1987/07/29	06830,163	1996/02/18
3369	P0267A	Power Circuit For Spectral Analysis Gaseous Discharge Lamps	United States	Granted	4,716,342	1987/07/29	06804,948	1996/02/18
3369	P0268A	Flame Atomic Absorption Spectrophotometer	United States	Granted	4,726,879	1988/02/23	06835,995	1996/04/25
3369	P0269A	Frictionless Translational Bearing	United States	Granted	4,684,811	1987/08/04	06835,995	1996/04/25
3369	P0270A	System for Calibrating A Monochromator	United States	Granted	4,779,216	1988/10/16	06837,434	1996/07/07
3369	P0271A	High Pressure Column Assembly For A Liquid Chromatograph	United States	Granted	4,876,005	1989/10/24	07261,374	1994/12/08
3369	P0271AEP	High Pressure Column Assembly For A Liquid Chromatograph	Europe	Granted	0328146	1993/08/20	89102368.1	1998/02/10
3369	P0271ADE	High Pressure Column Assembly For A Liquid Chromatograph	Germany	Granted	0328146	1993/08/20	89102368.1	1998/02/10
3369	P0271AGB	High Pressure Column Assembly For A Liquid Chromatograph	Great Britain	Granted	0328146	1993/08/20	89102368.1	1998/02/10
3369	P0272A	Programmable Lamp Plug	United States	Granted	4,670,813	1997/05/02	06802,924	1996/11/29
3369	P0273A	Phase Angle Measurement	United States					
3369	P0273AEP	Phase Angle Measurement	Europe					
3369	P0273AFR	Phase Angle Measurement	France					
3369	P0273ADE	Phase Angle Measurement	Germany					
3369	P0273AAT	Phase Angle Measurement	Italy					

3636	P0286ADE	Inductively Coupled Plasma Torch With Sample Injector	Germany	Granted	P-286962.4	1994/01/12	86103413.6	1988/07/04
3703	P0285ADE	Thermal Conductivity Detector	Germany	Granted	P-285754.1	1994/02/02	86103409.4	1988/03/04
3808	P0300ADE	Monochromator Drift Compensation	Germany	Granted	P-30013359.6	1994/03/02	86103940.3	1988/06/01
3937	P0297ADE	Power System For Inductively Coupled Plasma Torch	Germany	Granted	P-2970422.7	1994/06/29	86103403.7	1988/03/04
3527	P0287ADE	Low Frequency Signal Processing Circuitry	Germany	Granted	P-28716824.1	1994/07/12	85105604.3	1988/03/21
3536	P0287ADE	Detector Card For Spectrophotometer Used In Liquid Chromatography	Germany	Granted	P-28723389	1994/07/12	851056253.1	1988/03/21
4098	P0307ADE	Method And Apparatus For Comparing Spectra	Germany	Granted	P-30716635.4	1997/03/28	92110913.2	1992/10/02
4073	P0304ADE	Apparatus For Differential Analysis Of Sample Dielectric Properties	Germany	Granted	P-30420217	1998/09/17	63320217	1993/02/11
3628	P0284ADE	Analysis Of Organic Material	Germany	Granted	P-28420217	1995/07/26	86102940.9	1988/02/28
4637	P0327A	Zero-Dilution Split Injector Unit For Gas Chromatography	United States	Pending			80154.209	1993/08/16
4606	P0328A	Monitoring Constituents Of An Animal Organ Using Statistical Hybrid Filter Type Sensor	United States	Pending			08443.875	1993/11/18
4607	P0329A	Enclosure For Analytical Instrumentation	United States	Pending			08444.334	1993/11/19
4501	P0330A	Detection Of Low Level Analytes In Samples Using Agglutination	United States	Granted	D4.12.991	1999/08/17	281054.998	1997/01/16
3809	P0300AAU	Monochromator Drift Compensation	United States	Granted	5.942.442	1999/08/24	00831.206	1997/04/02
3809	P0300A	Monochromator Drift Compensation	Australia	Granted	612.847	1991/07/18	3987.489	1989/06/01
3809	P0300CA	Monochromator Drift Compensation	United States	Granted	4.916.845	1990/04/10	07201.250	1988/06/02
3826	P0018ADE	Circuit For Synchronizing Digital Signals With Alternating C	Canada	Granted	1.321.486	1993/08/24	601.458	1988/06/02
3828	P0018AGB	Circuit For Synchronizing Digital Signals With Alternating Cur	Germany	Granted	4.024.459	1991/02/07	P-4024459.8	1990/08/01
4015	P0024ADE	Vial Locator And Sensor	Great Britain	Granted	2.235.837	1993/06/16	9016500.6	1990/07/27
4015	P0024AEP	Vial Locator And Sensor	Germany	Granted	P-235109708.9	1995/06/17	91102281.2	1991/02/18
4015	P0024AAU	Vial Locator And Sensor	Europe	Granted	0444.498	1995/06/17	91102281.2	1991/02/18
4070	P0031AEP	Single Element Thermal Conductivity Detector	Australia	Granted	640.453	1993/06/26	7193391	1991/02/27
4070	P0031ADE	Single Element Thermal Conductivity Detector	Europe	Granted	0529285	1998/08/02	92112375.8	1992/07/20
4273	P0300A	Apparatus For Differential Analysis Of Sample Dielectric Properties	Germany	Granted	68228833.2	1998/08/02	92112375.8	1992/07/20
2730	P0278AGB	Detector Card For Liquid Chromatography	United States	Granted	5.309.310	1994/06/03	07845.994	1992/03/04
3536	P0288AGB	3 Point Banding Measuring System	Great Britain	Granted	0185926	1992/08/20	85114718.1	1985/11/18
3984	P0021AGB	Vial Locator And Sensor	Great Britain	Granted	0335288	1995/07/12	85105283.1	1995/03/23
4015	P0024AGB	Standardizing And Calibrating A Spectrometric Instrument	Great Britain	Granted	0428010	1994/06/01	90120859.5	1990/10/31
4045	P0027AGB	Photodetector Amplifier	Great Britain	Granted	0444.498	1995/06/17	91102281.2	1991/02/18
4063	P0028AGB	Photodetector Amplifier	Great Britain	Granted	0580006	1997/12/10	83100106.9	1993/10/07
4073	P0029AGB	Method Of Manufacturing Glass Beads	Great Britain	Granted	0532604	1997/04/09	93100102.8	1993/10/07
4076	P0030AGB	Apparatus For Differential Analysis Of Sample Dielectric Properties	Great Britain	Granted	2.261.869	1995/06/26	9235699.3	1992/11/11
4098	P0033AGB	Absorbance Correction In Atomic Absorption Spectroscopy	Great Britain	Granted	0558972	1998/04/12	93102188.7	1993/02/11
2856	P0027AGB	Method For Heating A Thermionic Detector Source	Great Britain	Granted	2.261.860	1995/04/02	9235648.0	1992/11/10
4056	P0031AGB	Variable Gain Amplifier	Great Britain	Granted	2.261.534	1995/12/06	9235389.5	1992/11/11
4086	P0034ADE	Double Beam Detector System For Liquid Chromatography	Great Britain	Granted	2.116.753	1996/01/29	98303865.5	1993/02/10
	P0033A	Photometric Instrument With Optical Fibers For Analyzing	Germany	Granted	0528541	1996/04/17	92114331.9	1992/04/21
	P0033A	Method For Processing A Sample	United States	Pending			P-442466.16	1994/07/14
	P0033A	Method For Processing A Sample	The Netherlands	Allowed			091101.819	1988/10/20
	P0033A	Method For Processing A Sample	PCT	Pending			11007110	1990/01/17
4462	P0326A	Detection Of Low Level Hydrophobic Analytes In Samples	Canada	Pending			PCT/NL97/00005	1997/01/07
4462	P0326AEP	Detection Of Low Level Hydrophobic Analytes In Samples	Europe	Pending			2.245.282	1997/04/02
4462	P0326AEP	Detection Of Low Level Hydrophobic Analytes In Samples	Japan	Pending			9891.4440.7	1999/04/02
4462	P0326A	Detection Of Low Level Hydrophobic Analytes In Samples	Australia	Pending			10.542004	1999/10/04
4501	P0330A	Detection Of Low Level Analytes In Samples Using Agglutination	Canada	Pending			12.245.219	1999/04/02
4501	P0330AEP	Detection Of Low Level Analytes In Samples Using Agglutination	Europe	Pending			9881.4435.7	1999/10/04
4501	P0330A	Detection Of Low Level Analytes In Samples Using Agglutination	Australia	Pending			66793088	1999/04/02
4501	P0330AEP	Method For Processing A Sample	Japan	Pending			10.541899	1999/10/04
4462	P0326A	Detection Of Low Level Hydrophobic Analytes In Samples	United States	Granted	5.891.740	1999/04/06	084832.168	1997/04/02
3729	P0033A	Detector For A Spectrometer	United States	Granted	4.820.048	1989/04/11	071123.025	1987/11/18
4086	P0028A	Photometric Instrument With Optical Fibers For Analyzing	Great Britain	Granted	2.312.044	1996/01/21	9714780.5	1997/07/14
4569	P0286A	Computer Operated Spectrometric Instrument	United States	Allowed			08300.809	1993/04/27
	P0033A	Method And Apparatus For Impurity Detection	United States	Pending			09503.092	2000/02/11
5002	P0033A	Method And Apparatus For Impurity Detection	United States	Pending			09561.800	2000/04/27

4484	P0035AAT	Fluid Conveying Device With Removable Connection	Italy	Pending				
	P0035AER	Fluid Conveying Device With Removable Connection	France	Pending				
	P0035ADE	Fluid Conveying Device With Removable Connection	Germany	Pending				
	P0035ACH	Fluid Conveying Device With Removable Connection	Switzerland	Pending				
	P0065AWD	Self Aligning Optical Fiber Terminator	PEC	Pending				
	P0037A	Non-Contacting Method of Cleaning Surfaces	United States	Granted	4,866,024	1990/06/11	PCT/US90/08687	2000/04/01
	P0037ACA	Non-Contacting Method of Cleaning Surfaces	Canada	Granted	1,315,823	1993/04/13	07/28/7,115	1989/04/07
	P0037AEP	Non-Contacting Method of Cleaning Surfaces	Europe	Granted	0324435	1989/07/19	88100346.9	1989/01/10
	P0037ADE	Non-Contacting Method of Cleaning Surfaces	Japan	Granted	1,225,125	1989/06/08	892,982	1989/01/10
	P0038A	Scanning Array Spectrophotometer	Germany	Granted	6,890,422	1993/01/10	809,422	1988/03/12
	P0038A	Method and Apparatus For Reactionless Robotic	United States	Granted	5,131,611	1992/07/21	06/03/8,658	1989/04/26
	P0042ADE	Nebulizer	Germany	Granted	683,320		P851,4470.2	
	P0042AGB	Nebulizer	United Kingdom	Granted	683,320		683,320	
	P0042ANI	Nebulizer	Netherlands	Granted	683,320		683,320	
	P0033AAU	Method For Processing A Sample		Granted	0529285	1998/08/02	92112315.8	1992/07/20
	P0033AIT	Single Element Thermal Conductivity Detector	Italy	Granted	2,616,819			
	P0027AJP	High Pressure Column Assembly For A Liquid Chromatograph	Japan	Granted	4,932,858	1990/08/28	186,545	1988/05/18
	P0038DA	Microphotograph Apparatus	United States	Granted	0342839	1989/11/23	89108854.4	1988/05/17
	P0038DAEP	Microphotograph Apparatus	Europe	Granted	2,035,709	1990/02/06	1223,023	1988/05/18
	P0038ACA	Microphotograph Apparatus	Japan	Granted	1,304,173	1992/06/23	899,723	1989/05/15
	P0038ADE	Microphotograph Apparatus	Canada	Granted	58926231	1995/02/08	623,233	1990/03/17
	P00361A	Design Of A Device For Sampling A Surface To Collect	Germany	Granted				
	P00362A	Dynamic Carrier For Reagents	United States	To File				
	P00363A	Low Cost Internal Calibration Standard	United States	To File				
	P00364A	Dual Photodiode Connection Of Background For Bioluminescence	United States	To File				
	P0139AGB	Atomic Absorption Spectrometer	Great Britain	Granted	2,180,064			
	P0280ADE	Gas Control Device For Controlling This Fuel Gas	Germany	Granted	P38/0372.9		P38/0372.9	
	P0280ADE	Conductive Coating To Eliminate Charge Effects And Radiation	Germany	Granted				
	P0285A	Semi-Check Switch And Switching Technique	United States	To File				
	P0287A	Dual Photodiode Connection Of Background For Bioluminescence	United States	To File				
	P0288A	Semi-Check Detection Of Inhibitory Components	United States	To File				
	P0039ADE	Grouping Of Spectral Bands For Data Acquisition	United States	To File				
	P0201AGB	Device For Igniting A Flame In An Atomic Absorption Spectrometer	Germany	Pending	2,180,328	1987/03/25	0621842	1986/09/10
	P0201ADE	Device For Igniting A Flame In An Atomic Absorption Spectrometer	Germany	Granted	P3532537.2	1987/03/19	P3532537.2	1985/08/17
	P0208DE	Gas Control Device For Controlling The Fuel Gas	Germany	Granted	3528547.3		60/210,256	2000/06/08
	P0211A	Method For Measuring Absolute Value Of Thermal Conductivity	United States	Pending	6,802,772		06/685,574	1997/12/05
	P0211A	Method Of Detecting Organisms In A Sample	United States	Granted		1998/05/11		
	P0212A	Method Of Detecting Organisms In A Sample	United States	Pending				
	P0212AWD	Method Of Detecting Organisms In A Sample	United States	To File				
	P0216A	RH Compensation By Nitrogen Coatings Of Electrochemical	United States	To File				
	P0217A	Planar Electrochemical Gas Sensor	United States	To File				
	P0218A	Electrochemical Gas Sensor With Miniaturized Flow Channel	United States	To File				
	P0218A	Electrochemical Gas Sensor With Miniaturized Flow Channel	United States	To File				
	P0280A	Electrochemical Sensor With Dry Nitrogen	United States	To File				
	P0281A	Integrated Electrochemical Gas Generator	United States	To File				
	P0282A	Prevention Of Flooding In Thick-Film Electrochemical Sensors	United States	To File				
	P0283A	RH Compensation For Electrochemical Sensors With Differential	United States	To File				